

# A charge pump system with new regulation and clocking scheme

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Abstract A novel charge pump system with new regulation and clock generating techniques is proposed and verified in a 0.13 µm CMOS process. Rather than generating the reference voltage by band-gap reference (BGR) and the detected voltage by high voltage divider in the conventional regulation, both voltage reference and division of proposed pump system are implemented by single new circuit. Besides, the conventional oscillator for clock input of charge pump system is removed while an adaptive clock generation scheme is introduced to reduce the power consumption and shrink the system size. The experiment results show that the pump system can produce a stable and smooth output with a small ripple, and the high output accuracy is comparable to the conventional solution equipped with BGR. Moreover, the power consumption of the pump controlling is reduced by about 80% while the size of pump system is decreased by about 25%. Therefore, the proposed regulated charge pump (RCP) is very suitable for ultra-low power and high precision applications, for example, the embedded nonvolatile memories (eNVMs). Keywords: charge pump, nonvolatile memory, clock generator, high voltage generating

Classification: Integrated circuits

### 1. Introduction

The common solid-state nonvolatile memories require charge pump system to generate high voltage for read and write operations, e.g. the split-gate embedded Flash memory requires 2.8 V voltage for read operation, 8 V voltage supply for program operation and 12 V for erase operation [1, 2, 3]. However, the area and power of eNVMs are mainly consumed by internal charge pump system [4, 5, 6]. And the needs of small chip area and ultra-low power eNVMs, which increases battery lifetime and reduces the cost, have become the key design aspects for portable equipment and internet-of-things (IoT) [7, 8, 9]. As a result, the advanced pump structures with smaller size and higher efficiency have been extensively researched [10, 11, 12, 13, 14, 15, 16, 17, 18, 19]. Meanwhile more attentions are paid to the regulation techniques [20, 21, 22, 23, 24, 25] or the clock inputs [26, 27, 28, 29, 30, 31] of charge pumps, since the regulation and clocking schemes

have also become more and more crucial to reduce power and chip size of pump system [4, 22].

Fig. 1(a) and Fig. 1(b) show the circuit diagram of a conventional regulated charge pump (RCP) system including a three-stage CMOS charge pump and a controller. And the conventional controller is composed of oscillator, voltage divider, band-gap reference and voltage comparator [32]. The oscillator generates the clock for the charge pump. Meanwhile, the BGR provides an accuracy voltage reference which will be compared to the detected voltage of charge pump output. As displayed in Fig. 1(b), the voltage  $V_{DET}$  detected via voltage divider can be expressed as  $V_{OUT}R_7/(R_7 + R_8 + R_9)$ . Fig. 1(c) shows the waveforms of conventional RCP system. When the pump system is enabled and  $V_{DET}$  is lower than  $V_{REF}$ , the comparator output EN will be high to enable RCP and oscillator. By contrast, when  $V_{DET}$  is higher than  $V_{REF}$ , EN will be low to stop RCP and oscillator. As a result, V<sub>DET</sub> is stabilized around  $V_{REF}$  and RCP output  $V_{OUT}$  approximately equals to  $V_{REF}(R_7 + R_8 + R_9)/R_7$ . In addition, a large decoupling capacitor  $C_{dcap}$  is required to reduce output ripple.

When it comes to low power consumption applications (low pump loading), the BGR and the oscillator (pump controlling) consume the majority of power and area of charge pump system. And, it is much difficult to reduce both of their power consumption and circuit size at same time. However, it is observed that sophisticated oscillator is not necessary, because the RCP is not frequently driven by clock and CMOS pump is not sensitive to clock duty cycle [19, 31]. In addition, the operational amplifier of comparator and the amplifier inside BGR are redundant in the closed loop of charge pump system. Hence, optimizing the regulation and clocking strategies may be a potential solution to reduce the power and area of pump system. In this paper, a new charge pump system with novel regulation and new clock generating schemes is proposed to reduce the chip size and power consumption. While, the precision of pump output is kept and the small output ripple is achieved. The rest of the paper is organized as follows. Section 2 presents the circuit structure, regulation and clocking strategies of the new pump system. In Section 3, experiment results are presented and analyzed. Conclusions are then given in Section 4.

#### 2. Proposed charge pump system

### 2.1 Circuit structure and regulation scheme

Fig. 2(a) illustrates the structure of the proposed charge pump system and Fig. 2(b) summaries the different regulation solutions between the conventional RCP and the

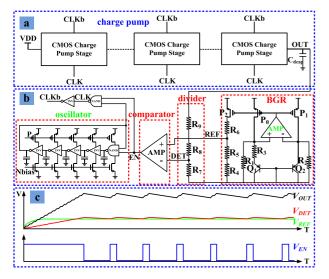
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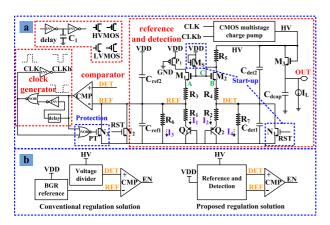
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**Fig. 1.** Conventional regulated charge pump system: (a) three-stage CMOS charge pump; (b) The conventional pump controller circuit; (c) Voltage waveforms of conventional charge pump system.

proposal. Rather than generating the reference voltage  $(V_{REF})$  by the dedicated BGR and the pump output division  $(V_{DET})$  by the dedicated voltage divider, the proposed PCP system use single circuit to implement both the voltage division and reference with one comparator (amplifier). In addition, the oscillator is no longer required in this system. But, an easy pulse generating circuit is introduced to provide the clock for this low-power charge pump system (its detailed operations are described in section 2.2). Compared with conventional solution shown in Fig. 1, the new system area is reduced by the size of one amplifier (inside the BGR) and the oscillator.



**Fig. 2.** Proposed charge pump system: (a) The proposed charge pump system circuit; (b) The comparison of regulation solutions.

As presented in Fig. 2(b), both of the voltages at node DET and REF ( $V_{DET}$  and  $V_{REF}$ ) of proposed pump system are determined by the pump output. The detailed relation between  $V_{DET}$  and  $V_{REF}$  depending on pump output  $V_{OUT}$  is demonstrated below. According to Fig. 2(a), if the system is active,  $V_{DET}$  and  $V_{REF}$  can be expressed as

$$V_{REF} = I_1 R_1 + V_{BE1} = I_1 R_1 + V_T \ln(nI_1/I_S)$$
(1)

$$V_{DET} = I_2 R_2 + V_{BE2} = I_2 R_2 + V_T \ln(I_2/I_S)$$
(2)

where  $V_{BE}$  is base-emitter voltage of bipolar,  $I_S$  is saturation current of bipolar  $Q_2$ ,  $V_T = KT/q$  and  $nQ_1 = Q_2$  (*n* is 16 in this design). Pump output *HV* is much higher than supply *VDD* in normal operation, while  $V_C$  is designed close to *VDD*. Therefore,  $M_1$  and  $M_2$  are both operated at saturation region and currents can be presented as

$$I_{1} + I_{3} = \frac{1}{2} \mu_{n} C_{ox} \frac{W_{1}}{L_{1}} (V_{C} - V_{A} - V_{th1})^{2}$$

$$= \frac{1}{2} \mu_{n} C_{ox} \frac{W_{1}}{L_{1}} [V_{C} - V_{REF} - (I_{1} + I_{3})R_{3} - V_{th1}]^{2}$$
(3)

$$I_{2} + I_{4} = \frac{1}{2} \mu_{n} C_{ox} \frac{W_{2}}{L_{2}} (V_{C} - V_{B} - V_{th2})^{2}$$

$$= \frac{1}{2} \mu_{n} C_{ox} \frac{W_{2}}{L_{2}} [V_{C} - V_{DET} - (I_{2} + I_{4})R_{4} - V_{th2}]^{2}$$

$$I_{0} = \frac{V_{REF}}{L_{2}} \frac{I_{1}R_{1} + V_{BE1}}{I_{1}R_{1} + V_{BE1}}$$
(4)

$$I_3 = \frac{\gamma_{REF}}{R_6} = \frac{\gamma_{REF}}{R_6}$$
(5)

$$I_4 = \frac{V_{DET}}{R_7} = \frac{I_2 R_2 + V_{BE2}}{R_7}$$
(6)

where  $\mu_n$ ,  $C_{ox}$ ,  $V_{th}$ , W and L with subscript denote the electrons mobility, gate oxide capacitance, threshold voltage, width and length of  $M_1$  and  $M_2$ . The pump output voltage is the sum of voltage drop on  $R_5$ ,  $M_2$ ,  $R_4$ ,  $R_2$  and  $Q_2$ . And the pump output HV minus the voltage drop on  $M_3$  ( $V_{GS,M3}$ ) equals the system output  $V_{OUT}$ , which can be written as

$$V_{OUT} = V_{BE2} + I_2 R_2 + (I_2 + I_4)(R_4 + R_5) + (V_C - V_B) - V_{GS,M3}$$
(7)

In equation (7),  $(V_C - V_B)$  could be simplified to  $V_{th2}$  and  $V_{GS,M3}$  is simplified to  $V_{th3}$ , since M<sub>1</sub>, M<sub>2</sub> and M<sub>3</sub> are selected with large width-to-length ratio. And the difference between  $V_{th2}$  and  $V_{th3}$ , induced by mismatch and body effect, can be further ignored compared to the large value of  $V_{OUT}$ . Therefore,  $V_{OUT}$  can be rearranged as

$$V_{OUT} = V_{BE2} + I_2 R_2 + \left(I_2 + \frac{I_2 R_2 + V_{BE2}}{R_7}\right)(R_4 + R_5)$$
(8)

In this design,  $M_1 = M_2$ ,  $R_1 < R_2$ ,  $R_3 = R_4$  and  $R_6 = R_7$ . When  $V_{DET} = V_{REF}$ ,  $I_3 = I_4$  can be easily derived from (5) and (6). And then,  $I_1 = I_2$  can be derived from (3) and (4). Defining  $\Delta R = R_2 - R_1$ ,  $I_0 = I_2$  and  $V_{OUT0} = V_{OUT}$  under the condition of  $V_{DET} = V_{REF}$ ,  $I_0$  and  $V_{OUT0}$  can be then calculated as

$$I_0 = \frac{V_T \ln n}{R_2 - R_1} = \frac{V_T \ln n}{\Delta R}$$
(9)

$$V_{OUT0} = \left(\frac{R_4 + R_5}{R_7} \frac{R_2}{\Delta R} + \frac{R_4 + R_5}{\Delta R} + \frac{R_2}{\Delta R}\right) V_T \ln n + \left(\frac{R_4 + R_5}{R_7} + 1\right) V_{BE2}$$
(10)

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When  $V_{DET} < V_{REF}$ ,  $(I_1 + I_3) < (I_2 + I_4)$  and  $I_3 > I_4$  can be demonstrated by (3) to (6). Taking these inequations into account, we can then get  $I_1 < I_2$ . Next,  $I_2 < I_0$  can be obtained by substituting  $V_{DET} < V_{REF}$  and  $I_1 < I_2$  into (1) and (2). Finally,  $V_{OUT} < V_{OUT0}$  can be concluded from (9) and (10). If  $V_{DET} > V_{REF}$ , on the contrary,  $V_{OUT} >$  $V_{OUT0}$  could also be proved by similar derivation. In this design, the value of  $V_{DET}$  and  $V_{REF}$  is determined by  $V_{OUT}$ . Thus, the relation between  $V_{DET}$  and  $V_{REF}$  can be concluded as: a)  $V_{DET} = V_{REF}$  when  $V_{OUT} = V_{OUT0}$ ; b)  $V_{DET} < V_{REF}$  when  $V_{OUT} < V_{OUT0}$ ; and c)  $V_{DET} > V_{REF}$ when  $V_{OUT} > V_{OUT0}$ .

According to above conclusions (a)-(c), by comparing  $V_{DET}$  with  $V_{REF}$  to control the clock generator and charge pump, the pump system output is regulated around  $V_{OUT0}$ . Therefore, the proposed regulation solution is functional, and the circuit size is smaller than conventional solution with divider and BGR. Furthermore, the resistor  $R_5$ ,  $R_6$  and  $R_7$  ( $R_6$  is kept same to  $R_7$ ) can be trimmed at the same time to achieve the desired value of pump output, according to (10). Meanwhile, negative or positive temperature coefficient can be effectively compensated to obtain temperature independent output. Also, V<sub>OUT0</sub> could be independent on *VDD*, since the voltage of node C ( $V_C$ ) is designed close to *VDD* to reduce the mismatch between  $M_1$  and  $M_2$ . Therefore, the proposed charge pump can provide precise and wide-range voltage according to different  $R_5 \sim R_7$  values. For example, Table I displays some output voltages with corresponding resistance values.

Table I.	Default resistance	for different	output voltage.

Output voltage	$R_2$	$R_3, R_4$	$R_5$	$R_6, R_7$
2.5 V	$2\Delta R$	4ΔR	15ΔR	Unuesd
8 V	$2\Delta R$	4ΔR	39.5∆R	9.5∆R
12 V	2ΔR	4ΔR	62.5ΔR	8.5∆R

#### 2.2 Self-adaptive clock generating scheme

No dedicated oscillator circuit is used in the proposed charge pump system, while a new clock generator is introduced with an easy delay circuit and some logic gates (Fig. 2). Fig. 3 shows the transient waveform of proposed RCP system including start-up, normal operation and protection phases controlled by the new clocking scheme. During normal operation, pump output drops with the time due to the pump loading  $I_L$ . Because the comparator is designed with high precision to detect the minute difference between  $V_{REF}$  and  $V_{DET}$ , the comparator output switches to low once  $V_{OUT}$  drops to slightly lower than  $V_{OUT0}$ . As displayed in Fig. 2(a), the falling edge of the comparator will produce a positive pulse at node CLK and a negative pulse at node CLKb by the clock generator. The charge pump is then driven by the pulse to boost the output voltage to be higher than  $V_{OUT0}$  (comparator output recovers to high). Thus,  $V_{OUT}$  is dynamically stabilized around  $V_{OUT0}$  (normal operation phase of Fig. 3). Because the clock is triggered when  $V_{OUT}$  drops to  $V_{OUT0}$ , the equivalent frequency of clock is adapted to the output loading.

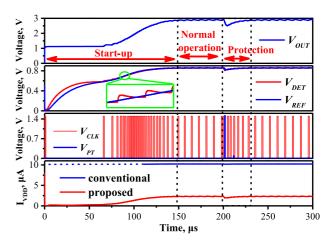


Fig. 3. Transient waveform of the proposed charge pump system.

During the start-up phase, a reset pulse is firstly applied to  $N_1$  and  $N_2$  to set  $V_{REF} = V_{DET} = 0$ . Then, the diode-connected transistor  $M_S$  provides a current path to turn on  $M_1$  and  $M_2$ . And the currents flowing through  $M_1$ and  $M_2$  charge the nodes REF and DET, respectively. Due to the fact that  $C_{det1}$  and  $C_{det2}$  are set much smaller than  $C_{ref1}$  and  $C_{ref2}$ ,  $V_{DET}$  is increased much faster than  $V_{REF}$ (charging currents through  $M_1$  and  $M_2$  are similar). However,  $V_{DET}$  is finally lower than  $V_{REF}$  under the condition  $V_{OUT} < V_{OUT0}$ , as derived in previous section. Thus, comparator output firstly switches to high level and then turns to low level. The falling edge of the comparator will generate a clock pulse to raise the pump output. Next,  $V_{DET}$  and  $V_{REF}$  are further increased by  $V_{OUT}$  rising, with the process where  $V_{DET}$  firstly exceeds  $V_{REF}$  and then lags behind  $V_{REF}$ . The clock pulse is produced again for the charge pump. Because of the differences between  $V_{DET}$  and  $V_{REF}$  on the rising speed and final value, the above process will be repeated until  $V_{OUT} > V_{OUT0}$  (start-up phase in Fig. 3).

By adopting  $N_3$  in Fig. 2, a protection strategy is introduced to prevent the system entering false state when there is an instantaneous large loading at OUT. As shown in Fig. 3, the false state means that  $V_{OUT}$  drops to lower than  $V_{OUT0}$  but could not be boosted to  $V_{OUT0}$  within one clock pulse. As a result, the comparator will keep low and no more clock pulse will be generated. In this case,  $N_3$  will be turned on to discharge the node REF until  $V_{DET} > V_{REF}$ . Next, similar to the procedure of start-up,  $V_{OUT}$  will then recover to  $V_{OUT0}$ .

Besides the small area and ultra-low power, another advantage of this clock generating circuit is the small pump output ripple. The standard expression for output ripple  $\Delta V$ can be given by

$$\Delta V = \frac{I_L \Delta t}{C_L} \tag{11}$$

where  $C_L$  is the capacitance loading of pump output including decoupling capacitor  $C_{dcap}$ ,  $I_L$  is the output loading, and  $\Delta t$  is the period of the ripple [30]. As displayed in Fig. 2(a), the clock for pump is immediately generated at the falling edge of the comparator. By comparison, the conventional solution needs additional time to turn on the oscillator, resulting in a longer  $\Delta t$  and a larger ripple. Therefore, the proposed RCP is able to achieve a smooth output with a small decoupling capacitor  $C_{dcap}$ .

#### 3. Experiment results

An eFlash memory testing chip was fabricated in HHGrace 130 nm CMOS process to demonstrate the proposed RCP system. Fig. 4 shows the microphotograph of the eFlash testing chip and the summary of power and area of pump system. The size of proposed RCP system is 0.026 mm<sup>2</sup>, which is decreased by 25% compared to conventional RCP system with same pump size. The power consumed by the pump controlling (excluding pump) is about 2.2  $\mu$ A, which is decreased by 80% compared to conventional RCP with the same current loading on pump output. Fig. 5 shows the measured waveform of the RCP output during read operation including start-up stage and normal operation stage. The start-up time is about 100 µs owing to the low-power feature of this RCP system. Also, the stable output (2.83 V) reaches the design targets of read operation (2.7 V-3 V), when the RCP system works at normal operation stage. Fig. 6 presents the output voltage of the conventional and the new RCP for program operation (8 V-8.2 V) after the calibration of  $R_5 \sim R_7$ . Measurement results show that the output voltage of proposed pump system has a low temperature coefficient of 85 ppm/°C with the temperature range from -40°C to +125°C. Meanwhile, the line sensitivity of the output is 3.6%/V only with supply range from 1.35 Vto 1.65 V. The precise RCP output is suitable for the eFlash memory and comparable to the conventional RCP with BGR.

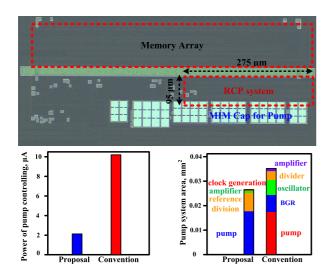
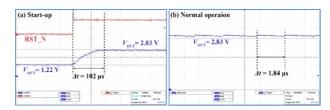
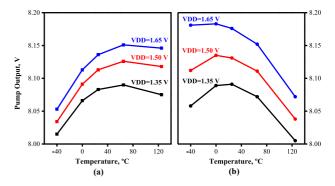


Fig. 4. Microphotograph of eFlash testing chip and the summary of power and area of pump system.



**Fig. 5.** Measured waveform of proposed RCP output for read operation: (a) Start-up stage; (b) Normal operation



**Fig. 6.** Measured program voltage related with temperature and supply: (a) conventional RCP output; (b) proposed RCP output

Table II. Comparison of regulated high-voltage charge pump.

	Luo [31]	Tsai [12]	Brandon [30]	Ravi [13]	This Work
Process (µm)	0.18	0.18	0.35	0.16	0.13
V <sub>IN</sub> (V)	3.3	1	2.5	3.3	1.5
V <sub>OUT</sub> (V)	10.5	3–6	7.5–16	16	2.7-12
Stage	3	6	6	_	3-10
Size (mm <sup>2</sup> )	1.3	0.5	0.069	1.65	0.026
Efficiency	69%	52%	34%	70%	49%
Ripple (mV)	260	39	18	160	36

Table II lists the performance comparisons among our regulated charge pump with the prior works [12, 13, 30, 31], which are capable of producing output voltages to higher than twice the supply voltage (*i.e.*,  $V_{OUT} > 2VDD$ ). The proposed RCP is realized by CMOS charge pump with bulk switching technique to achieve high power efficiency [14]. The results show the maximum output capability is 12 V and 0.6 µA with the high power efficiency of 49%, which is very suitable to eFlash memory in low-power applications. Additionally, a very small output ripple of 36 mV ( $C_{out} \approx 20 \text{ pF}$ ) is obtained owing to the new clock generating scheme. Among these works, the proposed charge pump system has the smallest size while obtains a high power efficiency and a low output ripple.

## 4. Conclusions

In this paper, we have presented the design and results of a novel charge pump system for generating high voltage. New regulation and clocking schemes are introduced to cut down the power consumption and reduce the pump size. Experiment results show the proposed pump system can produce the stable and smooth output with a small ripple, and the precision of output voltage is comparable to the conventional RCP. Moreover, the power consumption of the RCP controlling is reduced by about 80% while the pump system size is decreased by about 25%.

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